



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yoshinori Hino et al.                      Art Unit : 2826  
Serial No. : 10/076,154                                      Examiner : Tan N. Tran  
Filed : February 14, 2002  
Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF APRIL 5, 2004

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date of Deposit

*August 5, 2004*

Signature

*Paula T. Romeo*

*PAULA T. ROMEO*

Typed or Printed Name of Person Signing Certificate